

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2803	((kevin near2 shaw)(adams near2 scott)(davis near2 tim)(miller near2 scott)(lee near2 seung)(john near2 chong)).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/04 12:40
L2	68	((kevin near2 shaw)(adams near2 scott)(davis near2 tim)(miller near2 scott)(lee near2 seung)(john near2 chong)).in. and microelectromechanical	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/04 12:41
L3	291	(microelectromechanical and etch\$3).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/04 12:41
L4	9	(microelectromechanical and etch\$3 and metalliz\$3).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/04 12:42
L5	20	(microelectromechanical and etch\$3 and vias).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/04 12:42
L6	31	(microelectromechanical and etch\$3 and dielectric and silicon).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/04 12:42